PTO/SB/08A (08-00) - MODIFIED Approved for use through 10/31/2002. OMB 0651-0031 hge a plus sign (+) inside this box ™ Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE **Application Number** 10/039,618 Substitute for form 1449A/PTO **Filing Date** 1/4/02 ORMATION DISCLOSURE **First Named Inventor** Steven Teig TATEMENT BY APPLICANT Group Art Unit (use as many sheets as necessary) **Examiner Name** 1 SPLX.P0049 Sheet of **Attorney Docket Number** 

Examiner*	Cite	U.S. Patent Documer Number Kind Cod	Name of Patentee of Applicant	Date of Publication	Pages, Columns, Lines,
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<sup>&</sup>lt;sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

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**Application Number** 10/039,618 Substitute for form 1449A/PTO **Filing Date** 1/4/02 ORMATION DISCLOSURE **First Named Inventor** Steven Teig ATEMENT BY APPLICANT Group Art Unit <del>2811</del> 2825 (use as many sheets as necessary) **Examiner Name** 2 SPLX.P0049 **Attorney Docket Number** Sheet 2 .

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<sup>&</sup>lt;sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>5</sup> Applicant is to place a check mark here if English language Translation is attached.

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Approved for use through 10/31/2002. OMB 0651-0031
Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE Please type a plus sign (+) inside this box TM **Application Number** 10/039,618 Substitute for form 1449A/PTO 8 2003 APR Filing Date 1/4/02 FORMATION DISCLOSURE First Named Inventor Steven Teig TATEMENT BY APPLICANT Group Art Unit <del>2811</del> 2825 (use as many sheets as necessary) **Examiner Name** SUN J. LIN Sheet 3 3 of Attorney Docket Number SPLX.P0049

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<sup>\*</sup> EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

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	Sheet	4	of	4	Attorney Docket Number	SPLX.P0049

	NON PATENT LITERATURE DOCUMENTS	
Examiner* Initials	Cite Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Т
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Examiner Signature	Jan Sun Lin	Date Considered 2-25-0	
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	RELATED U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No. <sup>1</sup>	U.S. Patent Document Number	Date of filing MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Related Application Data	
	1.	2003/0079193	12-07-2001	Steven Teig et al:	Application with some of the same parent provisional and non-provisional applications.	
	2.	2003/0018947	12-07-2001	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.	
	3.	2002/0147958	10-19-2001	Steven Telg et al.	Parent application per preliminary amendment dated 2/19/03.	
	4.	2003/0083814	01-04-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.	
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	6.	2003/0101428 S/N 10/040,915	01-05-2002	Steven Telg et al.	Application with some of the same parent provisional and non-provisional applications.	
	<i></i>	Preliminary Amendment S/N 10/040,915	-01-05-2002-	=Steven=Teig-et-al.	This Preliminary Amendment is submitted as the publication 2003/0101428 does not accurately reflect-the claims of S/N 10/040,915.	
*	8.	2002/0166105 S/N 10/040,948	01-05-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.	
	9.	Preliminary Amendment S/N 10/040,948	01-05-2002	Steven Telg et al.	This Preliminary Amendment is submitted as the publication 2002/0166105 does not accurately reflect the claims of S/N 10/040,948.	
	10.	2003/0043827 S/N 10/040,953	<del>-01-05-2002</del>	-Steven Teig-et-al.	Application with some of the same parent provisional and non-provisional applications.	
	11:	Preliminary Amendment S/N 10/040,953	-01-05-2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2003/0043827 does not accurately reflect the claims of S/N 10/040,953.	
	12.	2003/0023943 S/N 10/040,954	01-05-2002	-Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.	

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Sheet	2	of	4	Attorney Docket Number	SPLX.P0049

		RELATED	J.S. PATENT DOCU	JIVIEN 13
13.	Preliminary Amendment S/N 10/040,954	-01-05-2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2003/0023943 does not accurately reflect the claims of S/N
14.	2003/0066042 S/N 10/040,963	01 05 2002	Steven Teig et al.	10/040,954.  Application with some of the same parent provisional and non-provisional applications.
15.	Preliminary Amendment S/N 10/040,963	01-05-2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2003/0066042 does not accurately reflect the claims of S/N 10/040,963.
16.	2002/0174412 S/N 10/041,942	01-07-2002-	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.
<del>-17.</del>	Preliminary Amendment S/N 10/041,942	01-07-2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2002/0174412 does not accurately reflect the claims of S/N 10/041,942.
18.	2003/0088844 S/N 10/041,957	01 07 2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.
-19.	Preliminary -Amendment S/N 10/041,957	01 07 2002	Steven Teig-et-al.	This Preliminary Amendment is submitted as the publication 2003/0088844 does not accurately reflect the claims of S/N 10/041,957.
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21.	Preliminary Amendment S/N 10/046,864	01 13 2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2002/0199165 does not accurately reflect the claims of S/N 10/046,864.
22.	2003/0066043	-01 13-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.
23.	2003/0115566	01-13-2002	Steven Teig	Application with some of the same parent provisional and non-provisional applications.
-24.	2003/0056187 S/N 10/047,982		Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.

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**Application Number** 10/039,618 Substitute for form 1449A/PTO Filing Date 1/4/02 INFORMATION DISCLOSURE First Named Inventor Steven Teig STATEMENT BY APPLICANT **Group Art Unit** <del>2811</del> 2825 (use as many sheets as necessary) **Examiner Name** SUN J. LIN Sheet of 4 3 Attorney Docket Number SPLX.P0049

		RELATED	J.S. PATENT DOCL	JMENTS
25	Preliminary Amendment	01 14 002	Steven Toig et al.	This Preliminary Amendment is submitted as the publication 2003/0056187 does not
-	S/N 10/047,982	0,1,002	Otovor Jug-Oron	accurately reflect the claims of S/N 10/047,982
- 26	2003/0066044	01 13 2002	Stoven-Teig et al.	Application with some of the same parent
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33		<del>-   12-13-2000 -</del>	Steven Teig et al.	the publication 2002/0073390 does not
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38		12-15-2000	Steven-Teig-et al.	the publication 2002/0124231 does not
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Information unless it contains a valid OMB control number **Application Number** 10/039.618 Substitute for form 1449A/PTO **Filing Date** 1/4/02 ORMATION DISCLOSURE **First Named Inventor** Steven Teig ATEMENT BY APPLICANT **Group Art Unit** (use as many sheets as necessary) **Examiner Name** Sheet 4 **Attorney Docket Number** SPLX.P0049

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- 30	<del>.   S/N 00/730,580-  </del> -	12 15 2000	Steven Teig et-al.	technology.
40	S/N-00/742,171	12-19-2000	Stoven Toig et al	Application regarding related placement
	. 0/14 00/142,111	12 10 2000-	Steven Teig et al.	technology.
	2003/0121015	12 18 2000	Steven Teig et al.	Application regarding related placement
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42		12-19-2000	Steven Teig et al.	the publication 2003/0121015 does not
42	S/N 09/745,067	12-13-2000	Steven Tely et al.	accurately reflect the claims of S/N
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	2002/0069397	01-13-2002	Steven Teig-et-al.	Application regarding related placement
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	2002/0170027	02-20-2002	Steven-Teig et al.	Application regarding related placement
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Substitute for form 1449A/PTO

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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	Application Number	10/039,618
	Filing Date	1/4/02
	First Named Inventor	Steven Teig
	Group Art Unit	2844 2825
	Examiner Name	SUN J. LIN
	Attorney Docket Number	SPLX.P0049

:			U.S. PATENT DOCUMENT	S	
Examiner* Initials	Cité No.1	U.S. Palent Document Number Kind Code <sup>2</sup> (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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type a plus sign (+) inside this box Palent and Trademark Office: U.S. DEPARTMENT OF COMMERCE **Application Number** 10/039,618 Substitute for form 1449A/PTO Filing Date 1/4/02 INFORMATION DISCLOSURE **First Named Inventor** Steven Teig STATEMENT BY APPLICANT Group Art Unit (use as many sheets as necessary) **Examiner Name** SUN J. 2 'Sheet 2 **Attorney Docket Number** SPLX.P0049

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**Application Number** 10/039,618 Substitute for form 1449A/PTO **Filing Date** 1/4/02 INFORMATION DISCLOSURE STATEMENT BY APPLICANT **First Named Inventor** Steven Teig Group Art Unit <del>2811</del> 2*9*25 (use as many sheets as necessary) SUN J. LIN **Examiner Name** SPLX.P0049 3 Sheet 3 **Attorney Docket Number** 

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Please types plus sign (+) inside this box **Application Number** 10/039,618 Substitute for form 1449A/PTO Filing Date 1/4/02 INFORMATION DISCLOSURE **First Named Inventor** Steven Teig STATEMENT BY APPLICANT 2814 2825 Group Art Unit (use as many sheets as necessary) SUN J. Examiner Name 4 Altorney Docket Number SPLX.P0049 of . Sheet ·4

	-	NON PATENT LITERATURE DOCUMENTS	
Examiner* Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>6</sup>
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Attorney Docket Number

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Sheet	1	of	4	Attorney Docket Number	SPLX.P0049

			RELATED U	.S. PATENT DOCU	MENTS
Examiner Initials	Cite No.'	U.S. Patent Document Number	Date of filing MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Related Application Data
FER	1.	2003/0079193	12-07-2001	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.
	2.	2003/0018947	12-07-2001	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.
	3.	2002/0147958	10-19-2001	Steven Teig et al.	Parent application per preliminary amendment dated 2/19/03.
	4.	2003/0063614	01-04-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.
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	7.	Preliminary Amendment S/N 10/040,915	01-05-2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2003/0101428 does not accurately reflect the claims of S/N 10/040,915.
	8.	2002/0166105 S/N 10/040,948	01-05-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.
	9.	Preliminary Amendment S/N 10/040,948	01-05-2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2002/0166105 does not accurately reflect the claims of S/N 10/040,948.
	10.	2003/0043827 S/N 10/040,953	01-05-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.
	11.	Preliminary Amendment S/N 10/040,953	01-05-2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2003/0043827 does not accurately reflect the claims of S/N 10/040,953.
PEL	12.	2003/0023943 S/N 10/040,954	01-05-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.

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•	RELATED U.S. PATENT DOCUMENTS								
ga	13.	Preliminary Amendment S/N 10/040,954	01-05-2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2003/0023943 does not accurately reflect the claims of S/N 10/040,954.				
	14.	2003/0066042 S/N 10/040,963	01-05-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.				
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	17.	Preliminary Amendment S/N 10/041,942	01-07-2002	Sleven Teig et al.	This Preliminary Amendment is submitted as the publication 2002/0174412 does not accurately reflect the claims of S/N 10/041,942.				
	18.	2003/0088844 S/N 10/041,957	01-07-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.				
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Examiner   Signature	Jamo Sun Bis	Date Considered	02-26-04

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Approved for use through 05/31/2003. OMB 0651-0031 a plus sign (+) inside this box 14 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of J information unless it contains a valid OMB control number **Application Number** 10/039,618 Substitute for form 1449A/PTO Filing Date 1/4/02 INFORMATION DISCLOSURE **First Named Inventor** Steven Teig STATEMENT BY APPLICANT 2814 2825 **Group Art Unit** (use as many sheets as necessary) Examiner Name SUN J. LIN 4 SPLX.P0049 Sheet 3 of **Attorney Docket Number** 

,			RELATED	J.S. PATENT DOCU	JMENTS
FR	25.	Preliminary Amendment S/N 10/047,982	01-14-002	Steven Teig-et al.	This Preliminary Amendment is submitted as the publication 2003/0056187 does not accurately reflect the claims of S/N 10/047,982
	26.	2003/0066044	01-13-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.
	27.	2003/0066045	01-13-2002	Steven Teig et al.	Application with some of the same parent provisional and non-provisional applications.
	28.	2003/0088845 S/N 10/047,978	01-13-2002	Steven Teig et al.	CIP of the present application per the preliminary amendment dated 2/19/03.
	29.	Preliminary Amendment S/N 10/047,978	01-13-2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2003/0088845 does not accurately reflect the claims of S/N 10/047,978.
	30.	2002/0133798	12-06-2000	Steven Teig et al.	Application regarding related placement technology.
	31.	2002/0100007	12-06-2200	Steven Teig et al.	Application regarding related placement technology.
	32.	2002/0073390 S/N 09/737,210	12-13-2000	Steven Teig et al.	Application regarding related placement technology.
	33.	Preliminary Amendment S/N 09/737,210	12-13-2000	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2002/0073390 does not accurately reflect the claims of S/N 09/737,210
	34.	S/N 09/737,220	12-13-2000	Steven Teig et al.	Application regarding related placement technology.
	35.	S/N 09/737,245	12-13-2000	Steven Teig et al.	Application regarding related placement technology.
	36.	S/N 09/739,460	12-15-2000	Steven Teig et al.	Application regarding related placement technology.
	37.	2002/0124231 S/N 09/739,580	12-15-2000	Steven Teig et al.	Application regarding related placement technology.
Far	38.	Preliminary Amendment S/N 09/739,580	12-15-2000	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2002/0124231 does not accurately reflect the claims of S/N 09/739,580.

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U.S. Palent and Trademark Office; U.S. DEPARTMENT OF COMMERCE Please type a plus sign (+) inside this box 19 Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number **Application Number** 10/039.618 Substitute for form 1449A/PTO **Filing Date** 1/4/02 ÍNFORMATION DISCLOSURE First Named Inventor Steven Teig STATEMENT BY APPLICANT **Group Art Unit** <sup>2811</sup> 2825 (use as many sheets as necessary) **Examiner Name** Sheet 4 of 4 Attorney Docket Number SPLX.P0049

•			RELATED (	J.S. PATENT DOCL	IMENTS
JA	<b>J</b> 39.	S/N 09/739,589	12-15-2000	Steven Teig et al.	Application regarding related placement technology.
	40.	S/N 09/742,171	12-19-2000	Steven Teig et al.	Application regarding related placement technology.
	41.	2003/0121015 S/N 09/745,067	12-19-2000	Steven Teig et al.	Application regarding related placement technology.
	42.	Preliminary Amendment S/N 09/745,067	12-19-2000	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2003/0121015 does not accurately reflect the claims of S/N 09/745,067.
	43.	2002/0069397	01-13-2002	Steven Teig et al.	Application regarding related placement technology.
	44.	2002/0170027	02-20-2002	Steven Teig et al.	Application regarding related placement technology.
	45.	2002/0157075	02-20-2002	Steven Teig et al.	Application regarding related placement technology.
	46.	2003/0088841 S/N 10/329,241	12-23-2002	Steven Teig et al.	Application regarding related placement technology.
FIR	/47.	Preliminary Amendment S/N 10/329,241	12-23-2002	Steven Teig et al.	This Preliminary Amendment is submitted as the publication 2003/0088841 does not accurately reflect the claims of S/N 10/329,241.

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Applicati n Number 10/039,618 Substitute for form 1449A/PTO Filing Dat 1/4/02 松FORMATION DISCLOSURE First Named Invent r Steven Teig STATEMENT BY APPLICANT 2825 **Group Art Unit** (use as many sheets as necessary) **Examiner Name** Lin, Sun J. 7 SPLX.P0049 of **Attorney Docket Number** Sheet 1

U.S. PATENT DOCUMENTS							
Examiner* Initials	Cite No.1		rment Code <sup>2</sup> (nown)	Date of Publication MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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	2.	2002/0182 844	A1	12-05-2002	lgarashi et al.		
	3.	2003/0005 399	A1	01-02-2003	lgarashi et al.	•	
	4.	5,267,176		11-30-1993	Antreich et al.		
	5.	5,566,078		10-15-1996	Ding et al.		
	6.	5,618,744		04-08-1997	Suzuki et al.		
	7.	5,635,736		06-03-1997	Funaki et al.		
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	9.	5,640,327	,	06-17-1997	Ting		
	10.	5,663,891		09-02-1997	Bamji et al.		
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`	17.	6,128,767		10-03-2000	Chapman		
	18.	6,150,193		11-21-2000	Glenn		
	19.	6,209,123	B1	03-27-2001	Maziasz et al.		
FER	20.	6,219,832	B1	04-17-2001	Buzbee		

Examiner Signature	Han Sun Liss	Date Considered	02-27-04
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!	Topics .			U.S.	. PATENT DOCUMENTS
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	22.	6,249,902	B1	06-19-2001	Igusa et al.
	23.	6,253,363	B1	06-26-2001	Gasanov et al.
	24.	6,307,256		10-23-2001	Chiang et al.
	25.	6,316,838	B1	11-13-2001	Ozawa et al.
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	36.	6,519,751	B2	02-11-2003	Sriram et al.
	37.	6,543,043	B1	04-01-2003	Wang et al.
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	39.	6,557,145	B2	04-29-2003	Boyle et al.
gar	40.	6,567,967	B2	05-20-2003	Greidinger et al.

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Sel	41.	JP	411296560	A	Matsumoto et al.	10-29-1999	with English translation of Abstract;		
	42.	JP	2000-82743	A	lgarashi et al.	03-21-2000	with Japanese Patent Office's English translation of Abstract; and with English translation of the application.	1	
	43.	JP	H03-173471	A	Tawada et al.	07-26-1991	with Japanese Patent Office's English translation of Abstract; and with English translation of the application.	1	
	44.	JP	H05-243379	A	Masako Kubota	09-21-1993	with Japanese Patent Office's English translation of Abstract; and with English translation of the application.	1	
	45.	JP	H05-102305	A	Akihiro Sato	04-23-1993	with Japanese Patent Office's English translation of Abstract; and with English translation of the application.	<b>√</b>	
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·	_	NON PATENT LITERATURE DOCUMENTS	
Examiner* Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>8</sup>
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